

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Grimbergen et al.	Group Art Unit: 1763
Application No: 09/595,778 Confirmation No: 6490	Examiner: Allan W. Olsen
Filed: June 16, 2000	Attorney Docket No: 2077 USA D01/ETCH/SILICON/JB1
Title: APPARATUS AND METHOD FOR MONITORING PROCESSING OF A SUBSTRATE	February 19, 2008 San Francisco, California

**AMENDMENT IN RESPONSE TO FINAL OFFICE ACTION**

VIA ELECTRONIC TRANSMISSION

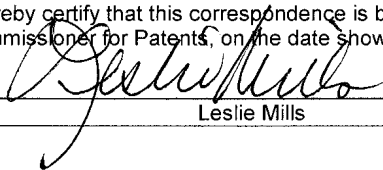
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This communication is in response to the Office Action mailed on  
September 19, 2007, and is being timely filed with a two-month extension of time.

**Certificate of Transmission**

I hereby certify that this correspondence is being electronically filed with the U.S. Patent Office, for the attention of the  
Commissioner for Patents, on the date shown below.

By  Date February 19, 2008  
Leslie Mills